



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
 www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 8933

SERIAL NUMBER 10/506,534	FILING OR 371(c) DATE 09/03/2004 RULE	CLASS 438	GROUP ART UNIT 2812	ATTORNEY DOCKET NO. 061063-0311751
APPLICANTS Takashi Shibayama, Kishima-gun, JAPAN; Yoshio Murakami, Saitama-shi, JAPAN; Takayuki Shingyoji, Saitama-shi, JAPAN;				
** C** NG DATA ***** This application is a 371 of PCT/JP03/02568 03/05/2003				
** FOREIGN APPLICATIONS ***** JAPAN 2002-261286 09/06/2002 JAPAN 2002-059182 03/05/2002				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met		STATE OR COUNTRY JAPAN	SHEETS DRAWING 8	TOTAL CLAIMS 5
Verified and Acknowledged Examiner's Signature <i>[Signature]</i> Initials <i>EH</i>	INDEPENDENT CLAIMS 1			
ADDRESS 00909				
TITLE Process for producing silicon single crystal layer and silicon single crystal layer				
FILING FEE RECEIVED 920	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	